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NGC-212/12-1167

**IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE**

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OCT 17 2005

Inventor(s): Raffi Nazare Elmadjian

Case No.: NGC-212/12-1167

Examiner

Ken Chan Chin

Serial No.: 10/688,238

Art Unit:

1765

Filing Date: 10/18/2003

Title: WAFER ETCHING TECHNIQUES

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being sent via facsimile transmission to Commissioner for Patents, Mail Stop Amendment, Group Art Unit 1765, Attention: Examiner Ken Chan Chin, P.O. Box 1450, Alexandria, VA 22313-1450, at fax number (571) 273-8300, on October 17, 2005.



Carmen B. Patti
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Reg. No. 26,784

Date of Signature: October 17, 2005

Commissioner for Patents
Mail Stop Amendment
Group Art Unit 1765
Attention: Examiner Ken Chan Chin
P.O. Box 1450
Alexandria, VA 22313-1450
Fax Number (571) 273-8300

AMENDMENT

Dear Sir:

This paper is filed in response to the Office Action mailed July 19, 2005 in connection with the above-identified application. A response to the Office Action is due October 19, 2005. Therefore, this Response is timely filed.

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